

PATENT
Attorney Docket No. 211843-00035

IN THE U.S. PATENT AND TRADEMARK OFFICE

Application No.: 10/825,339
Filing Date: April 15, 2004
Inventor(s): Thomas Neil Horsky
Group Art Unit: 2881
Examiner Name: Jack I Berman
Customer No.: 27160
Title: ION IMPLANTATION ION SOURCE,
SYSTEM AND METHOD

Confirmation No.: 8637

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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OFFICE OF PETITIONS

AMENDMENT

Sir:

In accordance with the concurrently filed Petition under 37 C.F.R. 1.78, please enter the following amendment:

Amendments to the specification are reflected on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.